

PATENT
ATTORNEY DOCKET: 46884-5345



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Satoshi MATSUMOTO et al.

Application No.: 10/518,392

Filed: July 25, 2005

For: LASER PROCESSING APPARATUS,
LASER PROCESSING
TEMPERATURE MEASURING
APPARATUS, LASER
PROCESSING METHOD, AND
LASER PROCESSING
TEMPERATURE MEASURING
METHOD

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)
) Confirmation No.: 8192
)
) Group Art Unit: 2855
)
) Examiner: Gail K. Verbitsky
)
)

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop AF
Alexandria, VA 22314

Sir:

**NOTICE OF APPEAL TO THE
BOARD OF PATENT APPEALS AND INTERFERENCES**

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the
decision of the Examiner dated April 3, 2008 finally rejecting claims 8-14.

1. Extension of Time

10/03/2008 SZEWD1E1 00000005 10518392

01 FC:1401

540.00 0P

02 FC:1253

1110.00 0P

The proceedings herein are for a patent application and the provisions of 37 C.F.R. § 1.136(a) apply.

- ☐ Applicants believe that no extension of time is required. However, this conditional petition is being made to provide for the possibility that Applicants have inadvertently overlooked the need for a petition and fee for extension of time.